

Notice of References Cited	Application/Control No. 10/591,977		Applicant(s)/Patent Under Reexamination CHIBA ET AL.	
	Examiner Leah Schlientz		Art Unit 1618	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-2004/0118701	06-2004	Senkiw, James Andrew	205/633
*	C	US-6,649,145	11-2003	McGrath et al.	424/45
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.